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AF/2800
AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2828
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q57433

Kiyoshi TAKEI, et al.

Appln. No.: 09/482,099

Group Art Unit: 2828

Confirmation No.: 6543

Examiner: Delma R. Flores Ruiz

Filed: January 13, 2000

For: DISTRIBUTED FEEDBACK TYPE SEMICONDUCTOR LASER DEVICE AND
METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 9, 2003, please amend the above-identified application as follows on the accompanying pages.

RECEIVED
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TECHNOLOGY CENTER 2800